Docket No.

212020US99



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tomasz KLOSOWIAK, et al.

GAU:

SERIAL NO: 09/911,444

EXAMINER: MONDT, J.P.

FILED:

July 25, 2001

STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR STRUCTURES AND DEVICES

FOR:

WITH OPTICAL PROCESSING LAYERS UTILIZING THE FORMATION OF A COMPLIANT

SUBSTRATE FOR MATERIALS USED TO FORM THE SAME

REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

It is hereby requested that a three month extension	of time be granted to July	12, 2002 for	
☑ filing a response to the Official Action dated:	March 12, 2002.		
responding to the requirements in the Notice of A	Allowability dated:		
☐ filing the Formal Drawings. The Issue Fee due has been timely file		has been timely filed.	
responding to the Notice to File Missing Parts of Application dated:			
iling a Notice of Appeal. A timely response to the final rejection, due			has been filed.
☐ filing an Appeal Brief. A Notice of Appeal was	filed on:		
☐ Applicant claims small entity status. See 37 CF			
The required fee of \$920.00 is enclosed herewith b Record's Deposit Account No. <u>15-0030</u> . A duplicat	by check and any further chate te copy of this sheet is encl	narges may be made aga losed.	inst the Attorney of

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAKER & NEWSTADT, P.C.

Richard L. Treanor

36,379 Registration No.

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 10-01)

jits assmand (10000000 09511946